

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Tsutomu OKABE, et al.

SERIAL NO: 10/706,914

GAU: 1792

FILED: November 14, 2003

EXAMINER: Moore, K.

FOR: WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION

**REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

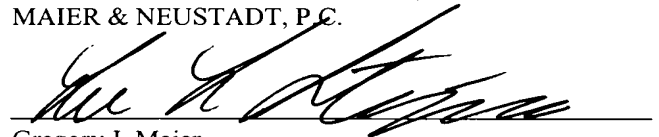
It is hereby requested that a **one** month extension of time be granted to July 27, 2008 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☒ filing a RCE.
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is being made by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
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